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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Ulrich C. Boettiger, Scott L. Light, William T. Rericha and
Craig A. Hickman

Application No. : 09/945,167 Confirmation No.: 1582

Filed : August 30, 2001

For : METHOD AND APPARATUS FOR IRRADIATING A
MICROLITHOGRAPHIC SUBSTRATE

Docket No. : 108298543US

Date : December 31, 2001

Commissioner for Patents
Washington, DC 20231

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PRELIMINARY AMENDMENT

Dear Commissioner:

In keeping with 37 C.F.R. § 1.121, this paper includes a clean version of the amended specification paragraph. An appendix is attached showing the marked-up version of the specification paragraph amended in the present response. Please amend the application as follows and reconsider the application in light of the following remarks.

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